Amendments to the Claims

1. (previously presented) A semiconductor bridge igniter comprising:

a substrate;

an electrical bridge structure disposed on the substrate, the bridge structure comprising a bridge section and pad sections, the bridge section extending between and connecting the pad sections, each pad section being of larger area than the bridge section, the pad sections and bridge section each comprising a layer of semiconductor material on the substrate and a layer of metal disposed on the semiconductor material, the layer of metal comprising titanium and the bridge section being free of a layer of tungsten; and

a pair of electrically conductive lands each overlying a respective one of the pad sections and being spaced apart from each other to leave the bridge section exposed.

2. (original) The semiconductor bridge igniter of claim 1 further comprising a pair of electrical leads, one connected to a respective one of the electrically conductive lands.

3. (original) The semiconductor bridge igniter of claim 2 further including a source of electrical energy connected to each of the electrical leads to define an electrical circuit extending from one lead, to one of the electrically conductive lands, through the bridge section, thence to the other electrically conductive land and the other electrical lead.

4. (original) The semiconductor bridge igniter of claim 3, wherein the source of electrical energy comprises a capacitor.

5. (canceled)

6. (previously presented) The semiconductor bridge igniter of claim 1 wherein the substrate comprises sapphire or a silicon dioxide layer.

7. (previously presented) The semiconductor bridge igniter of claim 1 wherein the semiconductor material has a negative coefficient of electrical conductivity at temperatures above ambient temperature.

8. (previously presented) The semiconductor bridge igniter of claim 7 wherein the semiconductor material comprises polysilicon or crystalline silicon.

9. (previously presented) The semiconductor bridge igniter of claim 1 wherein the semiconductor material comprises undoped crystalline silicon.

10. (canceled).

11. (previously presented) The semiconductor bridge igniter of claim 1 disposed in contact with an energetic material charge contained within the header of an igniter assembly.

12. (previously presented) A semiconductor bridge igniter comprising:

a substrate;

an electrical bridge structure disposed on the substrate, the bridge structure comprising a bridge section and pad sections, the bridge section extending between and connecting the pad sections, each pad section being of larger area than the bridge section, the pad sections and the bridge section each comprising a layer of a semiconductor material and a layer of metal comprising titanium disposed on the semiconductor material, the titanium having been preconditioned to be stabilized against temperature-induced variations in resistance; and

a pair of electrically conductive lands each overlying a respective one of the pad sections and being spaced apart from each other to leave the bridge section exposed.

13. (previously presented) The semiconductor bridge igniter of claim 12 comprising titanium preconditioned by heating the igniter to an elevated temperature of from about 37°C to about 250°C.

14. (previously presented) The semiconductor bridge igniter of claim 12 comprising titanium preconditioned by heating the igniter to an elevated temperature of from about 100°C to 250°C.

15. (previously presented) The semiconductor bridge igniter of claim 1, wherein each of the electrically conductive lands is disposed on the layer of metal comprising titanium.

16. (previously presented) The semiconductor bridge igniter of claim 15, wherein the electrically conductive lands comprise a metal selected from the group comprising aluminum, gold, silver, chromium, and combinations thereof.

17. (previously presented) The semiconductor bridge igniter of claim 12 further comprising a pair of electrical leads, one connected to a respective one of the electrically conductive lands.

18. (previously presented) A semiconductor bridge igniter consisting essentially of:

a substrate;

an electrical bridge structure disposed on the substrate, the bridge structure comprising a bridge section and pad sections, the bridge section extending between and connecting the pad sections, each pad section being of larger area than the bridge section, the pad sections and bridge section each comprising a layer of semiconductor material on the substrate and a layer of metal comprising titanium on the semiconductor material; and

a pair of electrically conductive lands each overlying a respective one of the pad sections and being spaced apart from each other to leave the bridge section exposed.

19 - 24. (canceled)

25 – 34. (canceled)

35. (previously presented) The semiconductor bridge igniter of claim 1 wherein the semiconductor material has, at ambient temperatures, a greater resistivity than the titanium and, at an elevated temperature lower then the melting point of the titanium, a lesser resistivity than the titanium.

36. (currently amended) ~~The semiconductor bridge igniter of claim 1,~~ A semiconductor bridge igniter comprising:

a substrate;

an electrical bridge structure disposed on the substrate, the bridge structure comprising a bridge section and pad sections, the bridge section extending between and connecting the pad sections, each pad section being of larger area than the bridge section, the pad sections and bridge section each comprising a layer of semiconductor material on the substrate and a layer of metal disposed on the semiconductor material, the layer of metal comprising titanium and the bridge section being free of a layer of tungsten; and

a pair of electrically conductive lands each overlying a respective one of the pad sections and being spaced apart from each other to leave the bridge section exposed;

wherein the layer of metal of the bridge section consists of titanium.